



<b>Search Notes</b>  	Application/Control No.  10693619	Applicant(s)/Patent Under Reexamination  RONNEKLEIV, ERLEND
	Examiner Detschel, Marissa J	Art Unit 2877

Notes	Date	Examiner
Confirmed IDS documents	09/28/2006	MJD
Updated EAST search	09/28/2006	MJD
Consulted Hwa Lee on case	9/28/06	MJD
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<p style="text-align: center;"><b>Searched</b></p> 	<p>Application/Control No.</p> <p>10693619</p>	<p>Applicant(s)/Patent Under Reexamination</p> <p>RONNEKLEIV, ERLAND</p>
	<p>Examiner</p> <p>Detschel, Marissa J</p>	<p>Art Unit</p> <p>2877</p>

Class	SubClass	Date	Examiner
356	477, 478, 479	09/28/2006	MJD
250	227.11, 227.18, 227.19, 227.23, 227.27	09/28/2006	MJD
385	12	9/28/06	MJD

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